



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 31, 2022	
IGI Report Number	LG520212373
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	7.69 X 5.65 X 3.90 MM
GRADING RESULTS	
Carat Weight	1.70 CARAT
Color Grade	H
Clarity Grade	VS 1
ADDITIONAL GRADING INFORMATION	
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LABGROWN IGI LG520212373

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process and may include post-growth treatment.
Type IIa

LG520212373

PROPORTIONS

Medium To Slightly Thick

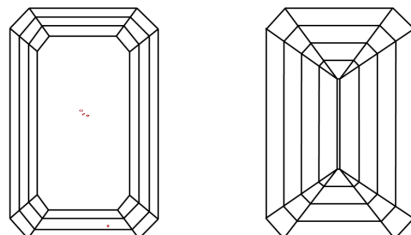
65%

69%

53%

Long

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

LABORATORY GROWN
DIAMOND REPORT

GRADING SCALES

COLOR GRADING SCALE	CL		NC	FT	VLT	LT
	COLORLESS D-F		NEAR COLORLESS G-J	FAINT K-M	VERY LIGHT N-R	LIGHT S-Z
CLARITY (10x) GRADING SCALE	FL	IF	VVS	VS	SI	I
	FLAWLESS INTERNALLY FLAWLESS		VERY VERY SLIGHTLY INCLUDED	VERY SLIGHTLY INCLUDED	SLIGHTLY INCLUDED	INCLUDED

LASERSCRIBESM

Sample Image Used

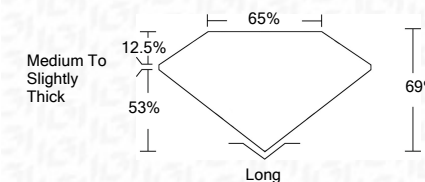


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GI Report No. LG60212373	
EMERALD CUT	
Carat Weight	1.70 CARAT
Culet Grade	V8 1
Clarity Grade	60%
Depth	69%
Table	
Girdle	Medium To Slightly Thick
Symmetry	Long
Fluorescence	EXCELLENT
Treatment(s)	EXCELLENT
Comments:	NONE
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Type Ia	

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